

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Lynn Forester, et al

Docket : 30-3928 (4780) DIV-1

Serial Number:

Group Art Unit:

Filed:

Examiner:

For: Electron-Beam Processed Films for Microelectronic Structures

PRELIMINARY AMENDMENT

Commissioner For Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

Prior to the substantive examination of this case, please amend the above identified patent application as follows: